

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: PARK, Woon-Yong; LEE, Won-Hee; KIM Il-Gon; LIM, Seung-Taek;
 SONG, You-Lee; and JUN, Sahng-Ik
 Assignee: Samsung Electronics Co., Ltd.

Title: THIN FILM TRANSISTOR ARRAY PANEL, MANUFACTURING
 METHOD THEREOF, AND MASK THEREFOR

Application No.: 10/771,278 Filing Date: February 2, 2004

Examiner: ROSASCO, Stephen D. Group Art Unit: 1756

Docket No.: AB-1353 US Confirmation No.: 2069

San Jose, California
 October 10, 2006

Mail Stop Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to the Restriction Requirement having a mailing date of September 7, 2006, Applicants hereby elect for further prosecution in this application the invention of Group I (Claims 1-5, drawn to a Thin Film Transistor array panel, classified in class 257, subclass 292).

Applicants withdraw the non-elected claims of Group II (Claims 6-9, drawn to a mask, classified in class 430, subclass 5) and Group III (Claims 10-23, drawn to a method of making a TFT array panel, classified in class 430, subclass 311), reserving the right to prosecute those claims in other applications.

The Examiner is invited to call the undersigned at (408) 392-9250 with any questions regarding the above-identified application.

EXPRESS MAIL LABEL NO.

EV 901 346 189 US

Respectfully submitted,

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